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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/007,484	11/07/2001	Neil S. Casa	5300-16	3613
75	90 12/10/2004		EXAM	INER
THOMAS LANGER,ESQ.			HASHMI, ZIA R	
COHEN, PONT 551 FIFTH AV	TANI, LIEBERMAN & P. ENUE	AVANE	HASHMI, ZIA R ART UNIT PAPER NUMBER	PAPER NUMBER
SUITE 1210			2881	
NEW YORK, 1	NY 10176		DATE MAILED: 12/10/2004	4

Please find below and/or attached an Office communication concerning this application or proceeding.

			A [™]			
	Application No.	Applicant(s)				
	10/007,484	CASA ET AL.				
Office Action Summary	Examiner	Art Unit				
	Zia R. Hashmi	2881				
The MAILING DATE of this communication Period for Reply	on appears on the cover sheet wi	th the correspondence addre	oss			
A SHORTENED STATUTORY PERIOD FOR F THE MAILING DATE OF THIS COMMUNICAT - Extensions of time may be available under the provisions of 37 (after SIX (6) MONTHS from the mailing date of this communicat - If the period for reply specified above is less than thirty (30) days - If NO period for reply is specified above, the maximum statutory - Failure to reply within the set or extended period for reply will, by Any reply received by the Office later than three months after the earned patent term adjustment. See 37 CFR 1.704(b). Status	CION. CFR 1.136(a). In no event, however, may a rion. s, a reply within the statutory minimum of thin period will apply and will expire SIX (6) MON statute, cause the application to become AB	eply be timely filed by (30) days will be considered timely. THS from the mailing date of this comm SANDONED (35 U.S.C. § 133).	unication.			
Status						
1) Responsive to communication(s) filed on						
·	This action is non-final.					
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims						
4) ☐ Claim(s) <u>1-32</u> is/are pending in the application Papers	thdrawn from consideration.					
9) The specification is objected to by the Ex	aminer					
10) The drawing(s) filed on is/are: a)		by the Examiner.				
Applicant may not request that any objection						
Replacement drawing sheet(s) including the			1.121(d).			
11)☐ The oath or declaration is objected to by t	•		7 7			
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for for a) All b) Some * c) None of: 1. Certified copies of the priority docu 2. Certified copies of the priority docu 3. Copies of the certified copies of the application from the International E * See the attached detailed Office action for	uments have been received. uments have been received in A e priority documents have been Bureau (PCT Rule 17.2(a)).	pplication No received in this National Sta	age			
Attachment(s)						
1) Notice of References Cited (PTO-892)		Summary (PTO-413)				
 Notice of Draftsperson's Patent Drawing Review (PTO-94) Information Disclosure Statement(s) (PTO-1449 or PTO/Paper No(s)/Mail Date 		s)/Mail Date nformal Patent Application (PTO-15 ·	52)			

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Art Unit: 2881

DETAILED ACTION

Election/Restrictions

1. Restriction to one of the following inventions is required under 35 U.S.C. 121:

I. Claims 1-30 drawn to a coupling for preventing transfer of vibrations between chambers, classified in class 73, subclass 663.

II. Claims 31-32 drawn to metrology system for inspecting wafers, classified in class 250, subclass 441.110.

Inventions I and II are unrelated. Inventions are unrelated if it can be shown that they are not disclosed as capable of use together and they have different modes of operation, different functions, or different effects (MPEP 806.04, MPEP 808.01). In the instant case the inventions are distinct, each from the other because of the following reasons:

With respect to Invention I, the coupling device is placed between first and second chambers for preventing transfer of vibrations between chambers and for sealing a passage between the first and second chambers.

With respect to invention II, the metrology system for inspecting wafers comprising a floating inspection chamber under vacuum, a fixed transfer chamber, a gate valve arranged between the chambers, and a coupling to prevent vibrations transfer.

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Conclusion

- 2. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact Electronic Business Center (EBC) at 866-217-9197 (toll-free).
- 3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Zia Hashmi whose telephone number is (571) 272-2473. The examiner can normally be reached between 8.30 ÅM- 5 PM. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee can be reached on (571) 272-2477.

Zia Hashmi

December 7, 2004

Nikuta Wells

PRIMARY EXAMINER 12/01/09